

## **LISTING OF THE CLAIMS**

This listing of claims will replace all prior versions, and listings, of claims in the application:

### **Claims 1-58 (Canceled)**

#### **Claim 59 (Currently Amended)**

In combination, a substrate processing apparatus and a substrate, wherein a processing liquid is supplied to one major surface of a substrate for a predetermined substrate processing, comprising:\_\_\_\_\_

three or more support members disposed in said processing apparatus, which abut a peripheral edge of said substrate and accordingly support said substrate;

said substrate having a notch at said peripheral edge of said substrate;

an atmosphere blocking member which faces another major surface of said substrate and is spaced away from said substrate;

said atmosphere blocking member having a radius which is smaller than a radius of said substrate by a radial width of a the notch at a the peripheral edge of said substrate, and is so constructed and arranged that a peripheral edge ~~area thereof~~ of said atmosphere blocking member is not exposed around said substrate through the notch;

wherein a substrate-facing surface of said atmosphere blocking member which faces the other major surface of said substrate becomes closer to the other major surface of said substrate with a distance toward said peripheral edge of said atmosphere blocking member;

~~said substrate-facing surface of said atmosphere blocking member is smaller in plan view than said substrate by a radial width of a notch at a peripheral edge of said substrate, and said atmosphere blocking member is so constructed and arranged that a peripheral edge area of said substrate-facing surface thereof is not exposed around said substrate through the notch;~~

said three or more support members being disposed at a said peripheral edge of said atmosphere blocking member; and

a gas supplying unit which supplies an atmosphere gas to a space which is created between said atmosphere blocking member and said substrate.

**Claim 60 (Previously Presented)**

The combination of claim 59, whereby the atmosphere blocking member prevents a mist from passing through said notch from said one major surface of said substrate, to said other major surface of said substrate.

**Claim 61 (Previously Presented)**

The combination of claim 59, wherein said atmosphere blocking member and said notched substrate cooperate to prevent a mist generated by liquid processing of said one major surface of said substrate, from passing through said notch and reaching said other major surface of said substrate.